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AF

Attorney Docket SEL 173

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
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Ohtani et al.)
)
Serial No.: 09/535,836)
)
Filed: March 28, 2000)
)
For: Semiconductor Device Having)
 Multi-layer Wiring)
)
Art Unit: 2811)
)
Examiner: H. Vu)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
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August 11, 2004

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.
Shannon Wallace 8/11/04

Signature

Date

AMENDMENT H (AFTER FINAL)

Sir:

In response to the Final Rejection Action dated May 14, 2003, please enter the following amendment in the above-identified application: